

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Bernhard Kneer et al. Art Unit : Unknown
Serial No. : To Be Assigned Examiner : Unknown
Filed : Herewith
Title : PROJECTION OBJECTIVE FOR A MICROLITHOGRAPHIC PROJECTION
EXPOSURE APPARATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form. Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature are enclosed. Copies of any listed U.S. patent application publications can be provided upon request. A copy of an International Search Report from a counterpart application is also enclosed.

This statement is being filed with the application. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: August 8, 2006

/Sean P. Daley/

Sean P. Daley
Reg. No. 40,978

Fish & Richardson P.C.
225 Franklin Street
Boston, MA 02110
Telephone: (617) 542-5070
Facsimile: (617) 542-8906

Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 18239-023US1	Application No.
Information Disclosure Statement by Applicant (Use several sheets if necessary)		Applicant Bernhard Kneer et al.	
		Filing Date	Group Art Unit
(37 CFR §1.98(b))			

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	2002/0163629	11/07/2002	Switkes et al.			
	AB	2004/0125351	07/01/2004	Krautschik			

Foreign Patent Documents or Published Foreign Patent Applications							
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation
							Yes No
	AC	EP 1 491 956	12/29/2004	EPO			
	AD	WO 2004/057589	07/08/2004	WIPO			
	AE	WO 2004/107048	12/09/2004	WIPO			English abstract

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AF	Lammers, “‘Doped water’ could extend 193-nm immersion litho,” <i>EETimes Online</i> , http://www.eetimes.com/showArticle.jhtml?articleID=18310517 , 2 pages (January 28, 2004)

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	